

Application Data Sheet

Application Information

Application number::	Not Yet Assigned
Application Type::	Regular
Subject Matter::	Utility
Suggested Group Art Unit::	N/A
CD-ROM or CD-R?::	None
Sequence submission?::	None
Computer Readable Form (CRF)?::	No
Title::	METHOD FOR REMOVING A RESIST MASK WITH HIGH SELECTIVITY TO A CARBON HARD MASK USED FOR SEMICONDUCTOR STRUCTURING
Attorney Docket Number::	543822003300
Request for Early Publication?::	No
Request for Non-Publication?::	No
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	India
Status::	Full Capacity
Given Name::	Srivatsa
Family Name::	KUNDALGURKI
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Country of Residence::	Germany
Street of mailing address::	Theodor-Fontane-Straße 5
City of mailing address::	Dresden
Country of mailing address::	Germany
Postal or Zip Code of mailing address::	D-01109

Correspondenc Information

Correspondence Customer Number:: 25227

Representative Information

Representative Customer Number:: 25227

Assignee Information

Assignee name:: Infineon Technologies AG

Street of mailing address:: St.-Martin Strasse 53

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